



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date: August 23, 2004

In re the Application of

Yasushi YAMASAKI et al.

Group Art Unit: 2811

Application No.: 09/970,766

Examiner: S. Hu

Filed: October 5, 2001

Docket No.: 110791

For: METHOD OF MANUFACTURING SEMICONDUCTOR SUBSTRATE, SEMICONDUCTOR SUBSTRATE, ELECTRO-OPTICAL APPARATUS AND ELECTRONIC EQUIPMENT

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Request for Continued Examination in response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired July 22, 2004, an extension of time for a period of one month is hereby requested. Attached hereto is our Check No. 157555 in the amount of \$110.00 in payment for:

 X Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
 Extension fee for response within second month pursuant to §1.136(a) (\$420.00)
 Extension fee for response within third month pursuant to §1.136(a) (\$950.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

Leana Levin

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